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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:  
Kevin M. Durocher et al.

Serial No.: 10/716,143

Filed: November 18, 2003

For: TECHNIQUES FOR FABRICATING  
A RESISTOR ON A FLEXIBLE  
BASE MATERIAL


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Group Art Unit: 2841

Examiner: Vigushin, John B.

Atty. Docket: RD27829-3/YOD  
GERD:0008-1

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

| CERTIFICATE OF MAILING<br>37 C.F.R. 1.8  |  |
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| I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date below: |  |
| July 12, 2006  |  |
| Date   | Marcie Alsbury   |

Dear Sir:

**RESPONSE TO OFFICE ACTION MAILED JUNE 20, 2006**

In response to the Office Action mailed on June 20, 2006, Applicants respectfully request reconsideration of the above-identified application in view of the remarks and amendments set forth below.